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B1b Data Sheet

CONFIRMATION NO. 2337

SERIAL NUMBER 10/501,672	FILING OR 371(c) DATE 07/16/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 2004_1129A
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## APPLICANTS

Hiroshi Takeno, Annaka-shi Gunma, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/00345 01/17/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-16663 01/25/2002

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after		
Verified and Acknowledged	Allowance <i>A. Onishi FH.</i> Examiner's Signature Initials		
STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
JAPAN	2	6	2

## ADDRESS

000513

## TITLE

Silicon epitaxial wafer and its production method

FILING FEE RECEIVED 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other <input type="checkbox"/> Credit
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